

Letters

FullMarch 2018

Rapid feedback of chemical vapor deposition growth mechanisms by operando X-ray diffraction

Aiden A. Martin, Philip J. Depond, Michael Bagge-Hansen, Jonathan R. I. Lee more...

Journal of Vacuum Science & Technology B **36**, 020601 (2018); <https://doi.org/10.1116/1.5019742>

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Interface states reduction in atomic layer deposited TiN/ZrO₂/Al₂O₃/Ge gate stacks

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Journal of Vacuum Science & Technology B **36**, 021201 (2018); <https://doi.org/10.1116/1.5006789>

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Band gap and strain engineering of pseudomorphic Ge_{1-x-y}Si_xSn_y alloys on Ge and GaAs for photonic applications

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***In situ* transformation and cleaning of tin-drop contamination on mirrors for extreme ultraviolet light**

Norbert Böwering, and Christian Meier

Journal of Vacuum Science & Technology B **36**, 021602 (2018); <https://doi.org/10.1116/1.5016821>

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Polycarbonate as a negative-tone resist for electron-beam lithography

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Role of ionic strength in the thicknesses of the biopolymer fringes, spring constants, and Young's moduli of *Pseudomonas putida*

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Direct formation of graphene on dielectric substrate: Controlling the location of graphene formation adopting carbon diffusion barrier

Ki-Ju Kim, Seong-Yong Cho, Hyun-Mi Kim, and Ki-Bum Kim

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Controlling defects in fine-grained sputtered nickel catalyst for graphene growth

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Fabrication of a compact glass-sealed x-ray tube with carbon nanotube cold cathode for high-resolution imaging

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***In situ* annealing of $\text{III}_{1-x}\text{Mn}_x\text{V}$ ferromagnetic semiconductors**

Xinyu Liu, Seul-Ki Bac, Pitambar Sapkota, Cameron Gorsak more...

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Dependence of ferromagnetic properties on phosphorus concentration in $\text{Ga}_{1-x}\text{Mn}_x\text{As}_{1-y}\text{P}_y$

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Site-controlled droplet epitaxy of GaAs quantum dots by deposition through shadow masks

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Reduced twinning and surface roughness of Bi₂Se₃ and Bi₂Te₃ layers grown by molecular beam epitaxy on sapphire substrates

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Normally-off operating GaN-based pseudovertical MOSFETs with MBE grown source region

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